			In
	Application No.	Applicant(s)	
Notice of Allowability	10/786,410	MAYDAN ET AL.	
	Examiner	Art Unit	
	Igwe U. Anya	2825	
The MAILING DATE of this communication appearable claims being allowable, PROSECUTION ON THE MERITS IS (wherewith (or previously mailed), a Notice of Allowance (PTOL-85) of NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RICE of the Office or upon petition by the applicant. See 37 CFR 1.313	OR REMAINS) CLOSED in this apport of the appropriate communication GHTS. This application is subject to	plication. If not include will be mailed in due	ed course. THIS
1. This communication is responsive to <u>01October 2004</u> .			
2. X The allowed claim(s) is/are 1-59.			
3. $igotimes$ The drawings filed on <u>01 October 2004</u> are accepted by the	Examiner.		
4.	been received. been received in Application No uments have been received in this of this communication to file a reply ENT of this application. ted. Note the attached EXAMINER is reason(s) why the oath or declara be submitted. on's Patent Drawing Review (PTO- Amendment / Comment or in the C B4(c)) should be written on the drawing header according to 37 CFR 1.121(c) it of BIOLOGICAL MATERIAL r	national stage applical complying with the red'S AMENDMENT or Nation is deficient. 948) attached office action of the dy. must be submitted. National stage application of the submitted.	quirements IOTICE OF
Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No /Mail Date 4/12/04, 5/28/04, 10/14/2/4 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	5. ☐ Notice of Informal P 6. ☐ Interview Summary Paper No./Mail Dat 7. ☐ Examiner's Amendr 8. ☑ Examiner's Stateme 9. ☐ Other	(PTO-413), te ment/Comment	,

Allowable Subject Matter

The following is an examiner's statement of reasons for allowance: Applicant's claims 1 – 59 are allowable, because prior art does not teach a method of fabricating a SOI, comprising inter alia:

(claim 1) generating an oxygen plasma current having a closed loop reentrant trajectory to a substrate having a silicon layer in reactor chamber; and

(claim 34) implanting oxygen below a silicon layer of a substrate, wherein the substrate is biased to a level corresponding to the implant depth.

- 2. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."
- 3. Prior art made of record and not relied upon considered pertinent to applicant's disclosure include Mahoney et al. (US 6432260), Liu et al. (US 2001/0017109), Henley et al. (US 6153524), Mizuno et al. (US 4837172), Chan (US 6632324), Henley et al. (US 6083324), Houston (US 6461933), and Cheung et al. (US 6344404).
- 4. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Igwe U. Anya whose telephone number is (571) 272-1887. The examiner can normally be reached on M F 8:30am 5:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Matthew S. Smith can be reached on (571) 272-1907. The fax phone

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number for the organization where this application or proceeding is assigned is 703-

872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Igwe U. Anya Examiner Art Unit 2825

IA

October 20, 2004

MATTHEW SMITH SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 2800